## **Zhizhong Yuan**

List of Publications by Year in descending order

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#	Article	IF	CITATIONS
1	Deformation microstructures of austenitic stainless steel 2Cr13Mn9Ni4 under ultrafast strain rate by laser shock processing. Materials Science & Engineering A: Structural Materials: Properties, Microstructure and Processing, 2013, 587, 244-249.	5.6	11
2	Silicon Nanocrystals as an Enabling Material for Silicon Photonics. Proceedings of the IEEE, 2009, 97, 1250-1268.	21.3	74
3	High-cycle fatigue behavior of high-nitrogen austenitic stainless steel. Materials Science & Engineering A: Structural Materials: Properties, Microstructure and Processing, 2009, 517, 257-260.	5.6	25
4	Enhanced photoluminescence of Tb3+ in SnO2 film by phosphorus diffusion process. Journal of Alloys and Compounds, 2009, 474, 246-249.	5.5	11
5	Electron-beam-induced current evidence for room-temperature photoluminescence of silicon pn diode. Vacuum, 2008, 82, 1337-1340.	3.5	3
6	Photoluminescence of Tb3+-doped SiNx films with different Si concentrations. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2008, 146, 126-130.	3.5	6
7	Impact properties of high-nitrogen austenitic stainless steels. Materials Science & Engineering A: Structural Materials: Properties, Microstructure and Processing, 2008, 475, 202-206.	5.6	24
8	Enhancement of ZnO light emission via coupling with localized surface plasmon of Ag island film. Applied Physics Letters, 2008, 92, .	3.3	156
9	Electroluminescence of SnO2â•p-Si heterojunction. Applied Physics Letters, 2008, 92, .	3.3	55
10	Correlation between luminescence and structural evolution of Si-rich silicon oxide film annealed at different temperatures. Journal of Applied Physics, 2007, 101, 103504.	2.5	29
11	Photoluminescence of Si-rich silicon nitride: Defect-related states and silicon nanoclusters. Applied Physics Letters, 2007, 90, 131903.	3.3	124
12	Effects of defect, carrier concentration and annealing process on the photoluminescence of silicon pn diodes. Materials Science in Semiconductor Processing, 2007, 10, 173-178.	4.0	4
13	Photoluminescence of Tb3+ doped SiNx films grown by plasma-enhanced chemical vapor deposition. Journal of Applied Physics, 2006, 100, 083106.	2.5	25